

Docket No. 102308-049

1763

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Tuqiang NI et al :
Serial No. 09/689,616 : Group Art Unit: 1763
Filed: October 13, 2000 : Examiner:
For: VACUUM PLASMA PROCESSOR HAVING A CHAMBER WITH ELECTRODES
AND A COIL FOR PLASMA EXCITATION AND METHOD OF OPERATING
SAME

INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner of
Patents and Trademarks
Washington, D. C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

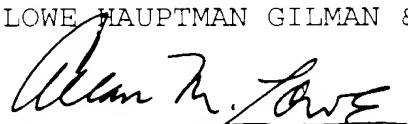
This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Serial No. sn

The relevance of each reference is discussed in the present specification.

Respectfully submitted,

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Date: February 6, 2001